भारतीय प्रौद्योगिकी संस्थान रोपड़
INDIAN INSTITUTE OF TECHNOLOGY ROPAR

सत्रार्ध ग्रेड रिपोर्ट
SEMESTER GRADE REPORT

NAME   SHUBHRA KAMAL NANDI
ENTRY NO 2019MEM1027
PROGRAMME M.TECH. MECHANICAL ENGINEERING (SPECIALIZATION IN MANUFACTURING ENGG.)

I SEMESTER 2019-2020

पाठ्यक्रम सं. COURSE NO	पाठ्यक्रम शीर्षक COURSE TITLE	क्रेडिट CREDITS	ग्रेड GRADE
ME501	MATHEMATICS FOR ENGINEERS	3	B
ME502	APPLIED NUMERICAL METHODS	3	A-
ME503	MEASUREMENT AND INSTRUMENTATION	3	B
ME547	ANALYSIS OF MATERIAL REMOVAL PROCESSES	3	A-
ME548	ANALYSIS OF CASTING,FORMING AND JOINING PROCESSES	3	A

EARNED CREDITS (EC)   =   15.00
SEMESTER GRADE POINT AVERAGE (SGPA)   =   8.80

CUMULATIVE EARNED CREDITS (CEC)   =   15.00
CUMULATIVE GRADE POINT AVERAGE (CGPA) =   8.80

Printed on:13-Feb-2020

DEPUTY REGISTRAR(ACADEMICS)

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II SEMESTER 2019-2020

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ME515	FINITE ELEMENT METHODS IN ENGINEERING	3	A
ME516	INTRODUCTION TO PLASTICITY	3	B
ME546	MICROMANUFACTURING	3	A-
ME550	SOLIDIFICATION PROCESSING	3	A-
ME559	COMPUTER INTEGRATED DESIGN AND MANUFACTURING SYSTEMS	3	B

EARNED CREDITS (EC)   =   15.00
SEMESTER GRADE POINT AVERAGE (SGPA)   =   8.80

CUMULATIVE EARNED CREDITS (CEC)   =   30.00
CUMULATIVE GRADE POINT AVERAGE (CGPA)   =   8.80

JOINT REGISTRAR(ACADEMICS)

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पाठ्यक्रम सं. COURSE NO	पाठ्यक्रम शीर्षक COURSE TITLE	क्रेडिट CREDITS	ग्रेड GRADE
ME504	DEEP LEARNING FOR PHYSICAL SYSTEMS	3	NP
ME699	PROJECT- I	16	A

EARNED CREDITS (EC) = 16.00
SEMESTER GRADE POINT AVERAGE (SGPA) = 10.00

CUMULATIVE EARNED CREDITS (CEC) = 46.00
CUMULATIVE GRADE POINT AVERAGE (CGPA) = 9.22

DATE: 21-JAN-2021

JOINT REGISTRAR(ACADEMICS)